



ELECTRONIC COPY

LG750567241
Report verification at igi.org



December 3, 2025

IGI Report Number **LG750567241**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **13.98 X 7.55 X 4.65 MM**

GRADING RESULTS

Carat Weight **2.77 CARATS**

Color Grade **E**

Clarity Grade **VVS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

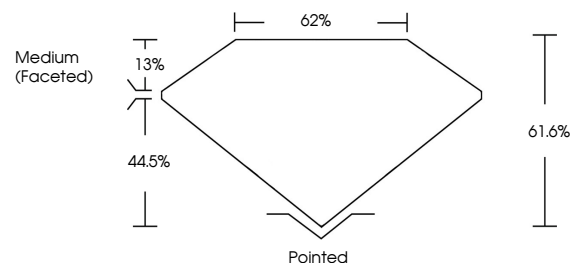
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG750567241**

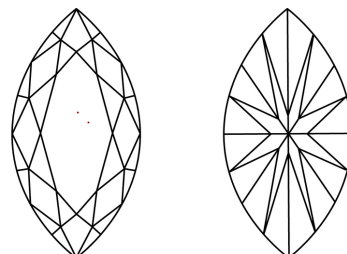
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

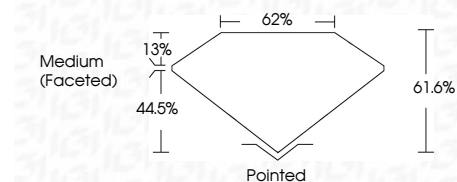
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



ADDITIONAL GRADING INFORMATION

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Fluorescence **NONE**

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December 3, 2025	IGI Report No LG750567241	MARQUISE BRILLIANT	13.98 X 7.55 X 4.65 MM	2.77 CARATS	E	VVS 1	61.6%	62%	Medium (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG750567241
Polish	Symmetry	Fluorescence	Inscription(s)	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Culet
EXCELLENT	EXCELLENT	NONE	IGI LG750567241	None	EXCELLENT	EXCELLENT	NONE	IGI LG750567241	None	EXCELLENT	EXCELLENT	NONE	IGI LG750567241	None

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